



COPY OF PAPERS
Attorney's Docket No.: 07977/097003/US3176D1D1
ORIGINALLY FILED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : H. Zhang
Serial No.: 09/804,654
Filed : March 12, 2001
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Art Unit : 2826
Examiner : F. Abraham

#19
F. Abraham

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated January 3, 2002,
Paper No. 7, in the above-referenced application, kindly
consider the following remarks in connection with the above-
identified application.

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TECHNOLOGY CENTER 2800

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

May 1, 2002

Date of Deposit

Signature

Susan Regan

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